

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 40%;">Application Number</td> <td>10/666,331</td> </tr> <tr> <td>Filing Date</td> <td>September 17, 2003</td> </tr> <tr> <td>First Named Inventor</td> <td>Shih, Hong</td> </tr> <tr> <td>Art Unit</td> <td>1792</td> </tr> <tr> <td>Examiner Name</td> <td>Unknown</td> </tr> </table>		Application Number	10/666,331	Filing Date	September 17, 2003	First Named Inventor	Shih, Hong	Art Unit	1792	Examiner Name	Unknown
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Sheet	1	of	1	Attorney Docket No: P1130/LMRX-P023											

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EXAMINER

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